

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q87270

Tsunehisa NAMIKI, et al.

Appln. No.: 10/530,357

Group Art Unit: 3742

Confirmation No.: 7770

Examiner: Quang T. VAN

Filed: September 23, 2005

For: METHOD OF FORMING A METAL OXIDE FILM AND MICROWAVE POWER  
SOURCE DEVICE USED FOR THE ABOVE METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action dated October 15, 2007, once extended from January 15, 2008 to February 15, 2008 by the filing of an appropriate petition and payment for extension of time submitted herewith, please amend the above-identified application as follows on the accompanying pages.

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